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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE NOV 30 2005

In Re Application of: Anderson *et al.* **Conf. No.:** 1115
Serial No.: 10/604,116 **Art Unit:** 2823
Filed: 06/26/2003 **Dkt. No.:** BUR920030031US1 (TBMB-0028)
Title: METHOD OF FORMING
FREESTANDING
SEMICONDUCTOR LAYER **Examiner:** Garcia, Joannie A

COMMISSIONER FOR PATENTS

DESTINATION FACSIMILE NUMBER: 571-273-8300Transmitted herewith is: **Amendment (12 pgs.)**

in the above identified application.

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FREESTANDING SEMICONDUCTOR
LAYER

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

I. INTRODUCTORY COMMENTS

In response to the Office Communication of November 1, 2005 and the Office Action of May 27, 2005, please amend the above-referenced patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims that begins on page 3 of this paper.

Remarks begin on page 9 of this paper.